

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Group Art Unit: 1792
)	
Yonhua Tzeng)	Examiner: Stouffer, Kelly M.
)	
Serial No.: 10/772,740)	
)	
Filed: February 5, 2004)	AMENDMENT AND RESPONSE TO
)	OFFICE ACTION MAILED
)	December 21, 2007
For: METHOD OF PLASMA)	
ENHANCED CHEMICAL VAPOR)	
DEPOSITION OF DIAMOND)	162 North Wolfe Road
USING METHANOL-BASED)	Sunnyvale, California 94086
SOLUTIONS)	(408) 530-9700
)	
)	Customer No.: 28960

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENTS

Sir:

Please amend the subject application as follows:

Remarks/Arguments begin on page 2 of this paper.